

Search Notes**Application/Control No.**

10/747,599

Examiner

George A. Goudreau

Applicant(s)/Patent under Reexamination

KIM ET AL.

Art Unit

1763

SEARCHED

Class	Subclass	Date	Examiner
438	257	4-071	GAG
438	266		GAG
438	289		GAG
438	296		GAG
438	593		GAG
438	595		GAG
438	596		GAG
438	696	4-071	GAG

**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
STN: CAPLUS, JADIO, INSPEC, USPATFULL	4-071	GAG
EAST: USPB, USPT, WPID, JPO	4-071	GAG

INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner
438	257	4-071	GAG
438	266		GAG
438	289		GAG
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Search Notes (continued) 	Application/Control No.	Applicant(s)/Patent under Reexamination
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